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AMENDMENTS TO THE CLAIMS:

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This listing of claims will replace all prior versions, and listing, of claims in the application.

Listing of the Claims:

- 1. (Currently amended) A field emitter composition comprising:
- a quantity of carbon black; and
- a quantity of a mixing medium;

wherein said quantity of carbon black is dispersed in said mixing medium that includes an ingredient selected from the group consisting of a photoresist, a polymer that is converted into diamond by heat, and a polymer selected from the group consisting of epoxies, polycurethanes, polyacrylates, polyesters, and polyimides.

2. (Cancelled)

- 3. (Currently amended) The invention of claim 1 wherein said mixing medium comprises a photoresist selected from the group consisting of a photosensitive photoresist or a non-photosensitive photoresist.
- 4. (Original) The invention of claim 1 wherein said field emitter composition is defined in a desired pattern.
- 5. (Original) The invention of claim 1 wherein said mixing medium has a viscosity of less than approximately 1500 cps.
- 6. (Original) The invention of claim 1 wherein said mixing medium has a viscosity of less than approximately 250 cps.
 - 7. (Original) The invention of claim 1 further comprising an organic solvent, said organic

solvent providing a desired viscosity to said field emitter composition.

- 8. (Original) The invention of claim 1 wherein said field emitter has an extraction field from about 1 V/ μ m to about 20 V/ μ m.
- 9. (Original) The invention of claim 1 wherein said carbon black comprises diesel fuel exhaust.

10-11. (Cancelled)

- 12. (Original) The invention of claim 4 wherein said field emitter forms part of an integrated circuit.
- 13. (Original) The invention of claim 1 wherein said field emitter composition is disposed on a substrate surface.
- 14. (Original)The invention of claim 13 wherein said substrate surface is planarized utilizing a chemical mechanical polishing step.
- 15. (Original) The invention of claim 13 wherein said substrate surface is a non-planar surface.
- 16. (Original) The invention of claim 1 wherein said mixing medium comprises a polymeric precursor to diamond like carbon.
- 17. (Original) The invention of claim 1 wherein said field emitter comprises a quantity of silica dispersed in said mixing medium.
 - 18. (Currently amended) A method of processing a field emitter formulation comprising the steps of: providing a first quantity of carbon black;

providing a second quantity of a mixing medium that includes an ingredient selected from the group consisting of a photoresist, a polymer that is converted into diamond by heat, and a polymer selected from the group consisting of epoxies, polyeurethanes, polyacrylates, polyesters, and polyimides;

mixing said first quantity of carbon black and said second quantity of said mixing medium to derive said field emitter formulation.

- 19. (Original) The method of claim 18 further comprising providing a third quantity of silica.
- 20. (Original) The method of claim 18 further comprising the step of measuring said field emitter formulation for a desired vertical resistance.
- 21. (Original) The invention of claim 18 wherein said mixing medium comprises a photoresist.
- 22. (Original) The invention of claim 18 wherein said mixing medium comprises a non-photoresist.
- 23. (Original) The invention of claim 18 further comprising the step of curing said field emitter formulation.
- 24. (Original) The method of claim 18 further comprising the step of applying said field emitter formulation onto a substrate.
- 25. (Original) The method of claim 24 wherein said substrate comprises a conductive material.
 - 26. (Original) The method of claim 24 wherein said substrate has a planar surface.

- 27. (Original) The method of claim 24 wherein said substrate has a non-planar surface.
- 28. (Original) The method of claim 24 wherein said substrate comprises a flexible substrate.
 - 29. (Withdrawn) An X-ray source comprising:
 - a substrate;
- a field emitter composition provided along a surface of said substrate, said field emitter composition comprising carbon black,
- a conductive layer provided along an upper support structure; such that when said conductive layer is struck by impinging high-energy electrons emitted from said field emitter composition, said upper support structure converts said impinging high-energy electrons into x-rays.
- 30. (Withdrawn) The invention of claim 29 wherein a grid is provided between said upper support structure and said conductive layer.
- 31. (Withdrawn) The invention of claim 29 wherein said carbon black is dispersed in a mixing medium.
- 32. (Withdrawn) The invention of claim 29 wherein said conductive layer comprises Mo, Cu, W, or other like material.
- 33. (Withdrawn) The invention of claim 29 wherein said upper support structure comprises a low atomic mass material.
- 34. (Withdrawn) The invention of claim 29 wherein said emitter composition further comprises silica.
 - 35. (Withdrawn) A high energy electron source comprising:

a substrate;

a field emitter composition provided along a surface of said substrate, said field emitter composition comprising carbon black;

an upper support structure comprising a plurality of apertures; wherein said structure also comprises an electron transparent film and also comprises a metallic grid; wherein energizing said metallic grid attracts electrons emitted from said field emitter composition.

36. (New) A method of processing a field emitter formulation comprising the steps of: providing a first quantity of carbon black;

providing a second quantity of a mixing medium;

mixing said first quantity of carbon black and said second quantity of said mixing medium to derive said field emitter formulation;

applying the formulation to a substrate and allowing the formulation to cure to form a substrate including a cured field emitter composition layer; and

planarizing the cured field emitter composition layer by chemical mechanical polishing.